

In re the Application of

Kazuhiro NAKAGAWA and Hiroyuki HIRAIWA

Application No.: New US National Stage of PCT/JP00/04466

Filed: March 5, 2001

Docket No.: 108776

For: METHOD OF MANUFACTURING SILICA GLASS MEMBER AND SILICA GLASS MEMBER OBTAINED BY THE METHOD

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INFORMATION DISCLOSURE STATEMENT

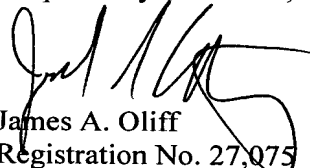
Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Japanese Patent No. 8-107060, No. 8-268726 and European Patent No. 0 401 845 A2 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,


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Date: March 5, 2001

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108776		APPLICATION NO. New US National Stage of PCT/JP00/04466 09/786470	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Kazuhiro NAKAGAWA and Hiroyuki HIRAIWA			
				FILING DATE March 5, 2001			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		JP A 8-5801 (w/ abstract)	01/12/1996	JAPAN			
		JP A 8-107060 (w/ abstract)	04/23/1996	JAPAN			
		JP A 8-268726 (w/ abstract)	10/15/1996	JAPAN			
		JP A 9-52722 (w/ abstract)	02/25/1997	JAPAN			
		JP A 11-54411 (w/ abstract)	02/26/1999	JAPAN			
		JP A 2000-7349 (w/ abstract)	01/11/2000	JAPAN			
		WO 98/00761 (abstract)	01/08/1998	WIPO			
		WO 98/52879	11/26/1998	WIPO			
		EP 0 401 845 A2	12/12/1990	Europe			
		EP 0 870 737 A1	10/14/1998	Europe			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							